Extending Probe Card Life for Fine Pitch Probe Cards

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Material Considerations

- Relative Accumulation
 - Comparison of 5 Common Probe Materials
 - Effects of Probe Tip Roughness
- Effect of Cleaning Materials
 - Comparison of 4 Common Probe Materials
 - Comparison of 5 Common Cleaning Materials



Accumulation Study

- 5 Probe Cards
 - One each of ReW, W, BeCu, P, NTK
 - Each Card with 10 Probes of the Same Material
 - Same Build Configuration
 - Study Conducted in Production Environment
 - No Electrical Testing
 - One Touch per die
 - 3 mil Overdrive
 - Same Test Condition for All Cards
 - No Cleaning



Probe 1 Comparison





Comparison Probe 1





Probe 1 Comparison





Probe 2 Comparison





Probe 2 Comparison





Probe 2 Comparison





Probe 3 Comparison





Probe 3 Comparison





Probe 3 Comparison





Accumulation Conclusions

- Relative Accumulation
 - ReW and W Accumulate at nearly the same rate
 - BeCu and NTK Accumulate at nearly the same rate
 - P Accumulation Rate Least of All Materials Studied
 - Substantial Difference in the Accumulation on ReW and P



Effect of Roughness

- Does the Probe Roughness Effect Accumulation Rates?
 - One ReW Probe Card
 - 100 Touchdowns After Sanding Flat with 3µm Lapping Film
 - 100 Touchdowns After Sanding Flat with 0.5µm Lapping Film
 - No Electrical Testing



0.5 μm vs 3 μm



Probes sanded with 0.5µm AIO2 lapping film, 100TD



Probes sanded with $3\mu m$ AlO2 lapping film, 100TD

ReW Probes, same probes, same OD



Roughness Conclusion

 Appears That Roughness Does Effect the Rate of Accumulation of Material on the Probe Tips



Durability Comparison

 "An Extremely Abrasive Analysis" Troy Harnish and Bill Wenholz, SWTW 2001



The Evaluation Basics

- Identical and simple probe cards
 - One probe card designated for each cleaning material
 - Cantilever design (epoxy ring)
 - Probe metallurgy and target size (flat)
 - Tungsten (25um)
 - Rhenium Tungsten (25um)
 - Beryllium Copper (25um)
 - Palladium (25um)
- Cleaning products in wafer format
- Common probe card metrology analysis
- Z only cleaning motion with indexing & OD extremes



3µm-LF SEM Comparison





Baseline

100k Touchdowns



0.5µm Cushion Lapping Film



Baseline

100k Touchdowns



Sanding Debris



Tungsten - 75µ l

Rhenium Tungsten - 80µ 1



Tungsten Carbide SEM Comparison



Baseline

500k Touchdowns



Tungsten Carbide Photos



Tungsten

Beryllium Copper



Custom Ceramic SEM Comparison



Baseline

500k Touchdowns



Custom Ceramic Photos



Mushroom Effect



Probe Polish 99 SEM Comparison



Baseline

1 Million Touchdowns



Durability Conclusions

- ReW and W Most Durable
- P and BeCu Much Less Durable
- Tungsten Carbide and Ceramic Less Destructive Than Any Lapping Film
- Probe Polish Least Destructive



Reshaping Tests

- On Going Research
- Goals
 - Reshaping Materials for Each Common Probe Materials
 - Control the Shape
 - Cost Effective Option to Extend Probe Card Life



BEFORE/AFTER





W Probe, 6000 Touchdowns



"X" DIAMETER CHANGE

TUNGSTEN PROBE RESHAPE





"Y" DIAMETER CHANGE

TUNGSTEN PROBE RESHAPE





Reshaping Recipe

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		-	Overdrive		78.0	76.1	76.0	78.0	76.0	76.0		75.0	76.0				
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			Fail		0	0	0.	0	0	0	0	0	NR				
			Not Found		0	Q.	0.	0.	0	D	0	0	NR.				
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A Tank	Passalts &	Summery /							14								1



Reshaping Plate





Tip Cleaning Window

Probe Tip Cleaning			<u>?</u> ×
<u>O</u> verdrive:	75.0	Microns	•
<u>P</u> attern:	Tip Reshape	1	•
Cleaning Material:	Probe Form		•
<u>T</u> otal Travel:	0.0	Microns	
<u>S</u> egment Travel:	0.0	Microns	
Angle:	0.000	Degrees	
Cycles Requested:	6000		
Cycles Completed:	0		
Status:	Ready		
Sand	Done	<u>H</u> elp	



Conclusion

- The Cleaning Recipe Must be an Integral Part of the Overall Test Program
- Different Probe Materials Accumulate Debris at Different Rates
- Surface Roughness Effects Debris Accumulation



Conclusion

- Material Used in Cleaning Dramatically Effects Probe Card Life
- Reshaping Probes can Extend Probe Card Life

